

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No. ....09/810,387  
Filing Date ..... March 15, 2001  
Inventor..... Craig M. Carpenter  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 1763  
Examiner ..... R. Zervigon  
Attorney's Docket No. ....MI22-1559  
Title: Chemical Vapor Deposition Apparatuses and Deposition Methods

**PRELIMINARY AMENDMENT TO ACCOMPANY RCE IN RESPONSE TO**  
**THE MAY 29, 2003 OFFICE ACTION**

To: MS RCE  
Art Unit 1763  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313

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**AMENDMENTS**